

PATENT
Docket No. SJO920010058US1

**IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE**

APPLICANT(S): **TSANN LIN**

SERIAL NO.: **10/066,835**

FILING DATE: **FEBRUARY 4, 2002**

TITLE: **IN-SITU OXIDIZED FILMS FOR USE AS GAP LAYERS FOR A SPIN-VALVE
SENSOR AND METHODS OF MANUFACTURE**

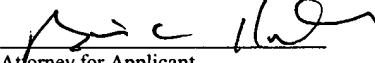
EXAMINER: **KEVIN M BERNATZ**

GROUP ART UNIT: **1773**

ATTY. DKT. NO.: **SJO920010058US1**

CERTIFICATE OF MAILING

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